

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : David L. Chapek  
Serial No. : 09/605,293  
Filed : June 28, 2000  
Title : SEMICONDUCTOR DEVICES INCLUDING A LAYER OF  
POLYCRYSTALLINE SILICON HAVING A SMOOTH  
MORPHOLOGY  
Docket No. : MIO 0037 VA/40509.118 (96-0831.01)  
Examiner : N. Drew Richards  
Art Unit : 2815  
Confirm No. : 5927

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

EFS Web Electronic Submission  
June 23, 2008

RESPONSE TO OFFICE ACTION

This Amendment is being filed in response to the non-final Office Action mailed March 28, 2008. Reconsideration and reexamination of the application is respectfully solicited in light of the remarks below.